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Response Under 37 C.F.R. 1.116
Expedited Procedure Examining
Group: 1763

PATENT
2658-0280P

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IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	Young Ho BAE	Conf. No.:	3483
Appl. No.:	10/029,035	Group:	1763
Filed:	December 28, 2001	Examiner:	R. N. KACKAR
For:	VACUUM DEPOSITION APPARATUS		

AMENDMENT UNDER 37 CFR §1.116

MS AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 19, 2004

Sir:

In response to the Examiner's final Office Action dated April 19, 2004, the period for response having been extended three (3) months to October 19, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This Amendment includes Amendments to the Specification (substitute specification); Amendments to the Claims; Amendments to the Drawings and Remarks.